



GP/2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fang Docket No.: 01-P-14755 US
Serial No.: 09/941,963 Art Unit: 2823
Filed: 8/28/2001 Examiner: Hsien-Ming Lee
For: Method of Cleaning an Inter-Level Dielectric Interconnect

RECEIVED
DEC -4 2002
TECHNOLOGY CENTER 2800

Certificate of Mailing via First Class Mail

Date of Deposit: November 25, 2002

I hereby certify that the below listed correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents, Washington, DC 20231.

Certificate of Mailing (1 page)
Response under 37 C.F.R. § 1.111 (2 pages)
Declaration filed under 37 C.F.R. § 1.131 (2 pages), including
Exhibits A – D (14 pages)
Return Postcard

Respectfully submitted,

Natalie Swider
Legal Assistant

Slater & Matsil, L.L.P.
17950 Preston Rd., Suite 1000
Dallas, TX 75252
Tel: 972-732-1001
Fax: 972-732-9218